

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 8995

Makiko KITAZOE et al.

Group Art Unit: 1792

Application No.: 10/593,444

Examiner: Joseph Albert MILLER, Jr.

Filed: February 5, 2007

Attorney Docket No.: 029567-00011

For: UNIT-LAYER POST-PROCESSING CATALYST CHEMICAL-VAPOR
DEPOSITION APPARATUS AND ITS FILM FORMING METHOD

RESPONSE UNDER 37 C.F.R. § 1.111

Mail Stop AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

August 2, 2010

Sir:

This paper is submitted in reply to the outstanding Office Action dated February 3, 2010. The period for response is extended three months, from May 3, 2010, to August 3, 2010, with payment of the appropriate fees

Claims 8-19 are rejected. No claims are amended. Claims 1-7 are withdrawn from further consideration in this application. Thus, Claims 1-19 are pending in this application. Applicants respectfully request reconsideration and withdrawal of all rejections and objections.

Rejection Under 35 U.S.C. §112

Claims 8-19 are rejected under 35 U.S.C. §112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which